

## Electronic Acknowledgement Receipt

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Title of Invention:	DUAL SILICIDE VIA CONTACT STRUCTURE AND PROCESS
First Named Inventor:	Michael M. Iwatake
Customer Number:	32074
Filer:	Yuanmin Cai/Amy Barger
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### File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment After Final	fis920040156AmendAfterFinal.pdf	304505	no	8

Warnings:		
Information:		
	Total Files Size (in bytes):	304505
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